

RFQ – Plasma Asher Descum System

We have been focusing on providing solutions and enhancements to [Matrix](#), [Branson/IPC](#), [Gasonics](#) used plasma Asher Descum semiconductor process equipment. These OEM semiconductor equipment have been used in productions and R&D since 1990's. They have been proven to be a true “work horse”. Allwin21 Corp. can customize these OEM systems with Allwin21's comparable [integrated process control system with PC](#), [solid robotic wafer transfer system](#) and new critical components to achieve the goal of giving our customers a production edge with right cost. Please help fill in the following Customer Survey Form for suitable model ([AW-105R, Downstream, Single Wafer, Automatic, the most popular](#); [AW-B3000, Batch, Manual load, low cost](#); [AW-1008, Single wafer, automatic](#)) and configuration for your applications. Appreciate your time. Thank you very much.

1. **Your Name(Required):**
2. **Your Email(Required):**
3. **Your Company Name(Required):**
4. **Company Address:**
5. Substrate materials, size?
6. Which Plasma Asher Descum Equipment you are looking for?
7. Your specifications of Asher/Descum Rates?
8. Your specifications of Asher/Descum Uniformity?
9. Maximum and lowest asher/descum temperatures?
10. Process gases and MFC flow rates?
11. Maximum and lowest plasma power (Watts)?
12. Did you use any Plasma Asher Descum Equipment which met your requirements? If yes, pls specify brand and model.
13. Do you know [Matrix](#), [Branson/IPC](#), [Gasonics](#) plasma asher equipment? If yes, pls tell us which model you know.
14. Approximate budget?
15. Approximate purchasing time?
16. Throughput Requirement?
17. Other special requirements: